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Modular systems for precision water vapour analysis of packaging film barriers



Applications

Barrier films PET bottles Flexible Pouches Containers Closures Bags

Features & Benefits

- **Analytical Systems Manufactured** traceable to NIST.
- System validation with certified gas or film for speed and convenience.
- Over 25 yrs experience of Proprietary Coulometric P₂O₅ sensor.
- Absolute moisture measurement No calibration required.

- Widest measuring range in the market providing research grade flexibility.
- Flow, temperature and humidity control for ultimate responsiveness and repeatability.
- Intuitive Windows based software.
- No liquid coolants, catalysts or special gas mixtures required.

Conforms to: **ASTM F-1249*** ISO 15106-3 ISO 15105-2 DIN 53122-2 rementation Environments Manufacturing essel Blanketing Istion Analysing iency Ultraviolet y Gas Production Powdered Metals ed Environments ns Manufacturing ocarbon Refining Food Packaging cs ■ Glove Boxes on Beam ■ R & D ■ Fermentation ed Environments s Manufacturing essel Blanketing stion Analysing ency Ultraviolet Gas Production wdered Metals **Environments** Manufacturing iel Blanketing on Analysing y Ultraviolet s Production lered Metals vironments nufacturing Analysing

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Manufacture traceable to NIST

All Systech Illinois analysers are certified traceable to NIST. In addition, analytical performance is validated using NIST certified gases and NIST traceable films. A set of validation films and a spare P_2O_5 sensor comes as standard with all of the water vapour permeation analysers.

P₂O₅ Sensor Technology

The two most common sensor types for measuring moisture are IR (infra-red) and P_2O_5 (phosphorous pentoxide). The P_2O_5 sensor is more sensitive and stable than IR and does not require calibration. P_2O_5 is the primary method for absolute moisture measurement. Systech Illinois have over 25 years experience of using P_2O_5 sensor technology.

*The Systech Illinois 7000 analysers comply with ASTM standard F-1249 with the exception of the sensor technology. The standard relates to an infra-red sensor whilst the Systech Illinois analyser uses a coulometric sensor - a dedicated method of moisture analysis.

Widest measuring range

The 7000 series offer you the widest measurement range in the market providing research grade flexibility.

- Measurement range of 0.002-1000 g/m²/day with masking.
- Quality Assurance orientated speed and agility.
- Up to five expansion modules available to increase testing throughput.



Precision control

These analysers offer precision temperature and humidity flow control providing ultimate responsiveness and repeatability.

- Test gas and carrier flow gas controlled by premium electronic mass flow controllers.
- Widest sample temperature range available of 5 to 50°C.
- Accurate relative humidity range from 20% to 90%.

Laboratory Testing Services

Our test laboratory will perform your Permeation Testing and Headspace Analysis. Whether you are developing innovative materials and packages or validating that your supplier is meeting specification. We can exceed your expectations with:

- Competitive Prices
- Fast Turnaround

- Independent non-biased results
- 25 Years Experience

Software)

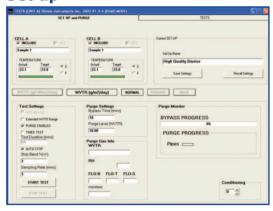
The intuitive Windows based software offers:

- Easy input and recall of operating parameters and test protocols.
- User-friendly data tracking, searches, sorts, storage and output capabilities.
- Graphical representation of measurement data in real time.
- Auto-stop feature stops test when samples have reached equilibrium or by user entered elapsed time value.
- Complete system diagnostics.

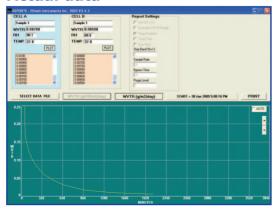
Start up



Set up



Actual data

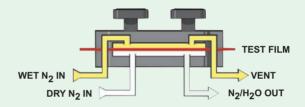


Principle of Operation

Utilising our proprietary sensor technology to detect water vapour transmission rates, samples are clamped or attached to a diffusion chamber. Wet nitrogen is then introduced into the upper half of the chamber while a moisture-free carrier gas flows through the lower half.

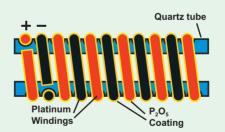
Molecules of water diffusing through the sample into the lower chamber are conveyed to the sensor by the carrier gas.

Sample Test Chamber



This allows a direct measurement of the water vapour without using complex extrapolations. Water vapour transmission rate of the test sample is displayed as either g/m²/day or g/100in²/day.

P₂O₅ Sensor



To achieve an absolute measure, the technology draws upon a fundamental principle of physics.

The phosphorous pentoxide (P₂O₅) moisture sensor consists of a dual platinum winding formed around a quartz tube.

The change in the resistance across the windings creates a change in the measured current. According to Faraday's Law this is directly proportional to the amount of moisture in the gas stream.

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DOW

7000 Series - Water Vapour Permeation Analysers

Systech Illinois' range meets the requirement for the testing of any application.



Systech Illinois' 7002 Water Vapour Transmission Analyser delivers the same high performance as the 7001 but with an extended measurement range for more demanding applications.

Technical Specifications

Measurement Range

7001 Unmasked 0.002 to 10 g/m²/day Masked 0.02 to 70 g/m²/day 7002 Unmasked 0.002 to 70 g/m²/day 0.02 to 1000 g/m²/day Masked

Test Temperature Range 5°C to 50°C (41°F to 122°F)

Test RH Range 20 to 90% RH

Sample Size 50cm², adaptors available for smaller samples

Operating Conditions Standard laboratory environment

Power Requirements 100-240 VAC, 50/60Hz, 840 VA (max)

Supply Pressure 1.7 bar regulated

Gas Fittings 1/8 in. Swagelok (supplied)

Enclosure Epoxy coated heavy gauge steel

Dimensions 533 x 533 x 305 (mm)

Weight 23.6kg

Options

Expansion Modules 7011 Available for simultaneous WVTR

analysis of up to 12 samples

Environmental Chambers For finished package testing

Systech Illinois have over 25 years experience of providing analysis solutions for a wide range of industries. From our manufacturing plants in the UK and U.S we produce gas analysers for industrial process industries, headspace analysers for monitoring gas flushing of food products, and our range of permeation analysers.

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Controlled E ontact Lens M inealing **=** Ve amics Combust Oxygen Deficier s
High Purity ■ Alloys and Po lity ■ Controlled ☐ Contact Lens keting ■ Hydroc on Analysing **T** F ass/Fibre Optics uction ■ Electron Ndered Metals ity ■ Controlled ■ Contact Lens N Annealing ■ Ves ramics Combust Oxygen Deficien ■ High Purity G Alloys and Pow ■ Controlled Er ontact Lens Ma aling ■ Vessel cs Combustion n Deficiency (h Purity Gas and Powder ntrolled Envir g ■ Food Pa ens Manut ■ Vessel BI ombustion A Deficiency U h Purity Gas I